

10/090007

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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10090807	FILING DATE 03/06/2002	CLASS 430	SUBCLASS 30	GAU 1756	EXAMINER Young
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****APPLICANTS:** Hong Hyung-Sik; Shin Dong-Wha; Min Byung-Ho; Choi
Jae-Hong;

****CONTINUING DATA VERIFIED:**

**** FOREIGN APPLICATIONS VERIFIED:**
REPUBLIC OF KOREA 2001-11540 03/06/2001

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no
Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

253/010

TITLE : Method for exposing a peripheral area of a wafer and apparatus for performing the same

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	Total Claims Print Claim Fee O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg. Print Fee
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner	Application Examiner
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